ELSEVIER

Thin Solid Films 268 (1995) 161

thin solid films

Author Index of Volume 268

Ahmed, E., 144
Alexandrou, I., 57
Antolini, F., 108
Antonopoulos, J., 1
Aungkavattana, P., 102

Barna, P.B., 57
Bialas, H., 35
Blomberg, M., 72
Bogy, D.B., 83
Brink, D.J., 98

Černý, R., 72
Chiu, C.-C., 91
Conrad, J., 39

De Schryver, F.C., 114
Diesner, K., 130
Doña, J.M., 5
Dubrovsky, T., 108

El Bouchikhi, A., 13

Frangis, N., 57

Georgoulas, N., 1
Geyer, U., 39
Girginoudi, D., 1
Girginoudi, S., 1
Glisenti, A., 22
Goitia, J., 22
Gossla, M., 39
Gouws, G.J., 98
Gu, P.F., 137

Haartz, B., 102
Hahn, Th., 39
Haidoux, A., 13
Hauert, R., 22
Hermsmeier, B.D., 22
Herrero, J., 5
Hill, A.E., 144
Hoffmann, P., 22
Huang, L., 49

Janietz, D., 121
Jutila, A., 121

Kadlec, S., 72
Kartouni, K., 45
Kaufman, J.H., 22
Kellock, A.J., 22
Kleperis, J., 140
Kunert, H.W., 98
Kuwano, H., 152
Kužel, Jr., R., 72

Lefez, B., 45
Lemmetyinen, H., 114, 121
Lenglet, M., 45
Lewerenz, H.-J., 130
Li, H.F., 137
Liou, Y., 91
Liu, X., 137
Lloyd Spetz, A., 140
Logothetidis, S., 57
Lu, C.-J., 83
Lundström, I., 140
Lusis, A., 140

Merisalo, M., 72
Metin, S., 22
Metzner, H., 39
Meyers, E.A., 49

Nair, M.T.S., 49
Nair, P.K., 49
Nakano, S., 152
Nicolini, C., 108
Niess, J., 35

Okui, N., 18
Oliveira, L., 30
Omichi, H., 18

Paddeu, S., 108
Papet, P., 13
Pécz, B., 57
Philippot, E., 13
Pilkington, R.D., 144
Reiche, J., 121
Reiprich, S., 64
Rosenblum, S.S., 83
Ruud, C.O., 102

Scheer, R., 130
Siu Li, M., 30
Souchet, R., 45
Stoemenos, J., 1, 57
Sugimoto, I., 152
Sundgren, H., 140

Tamada, M., 18
Tang, J.F., 137
Tessmer, G.J., 83
Thanailakis, A., 1
Tomlinson, R.D., 144
Trolier-McKinstry, S., 102

Valvoda, V., 72
Van der Auweraer, M., 114
Van Loosdrecht, P.H.M., 22
Vepřek, S., 64
Vuorimaa, E., 114

White, R.L., 22
Winquist, F., 140

Zegadi, A., 144
Zheng, Z.D., 137
Zingaro, R.A., 49
Zubkans, J., 140

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ELSEVIER

Thin Solid Films 268 (1995) 162–164

thin solid films

Subject Index of Volume 268

Alkali halides
off-center effect of Cu^+-doped KCl films studied by optical absorption and thermally stimulated depolarization current, 30
Amorphous materials
influence of nitrogen doping on different properties of a-C:H, 22
Anisotropy
photophysical investigation of Langmuir–Blodgett films of amphiphilic discotic penta-alkynes, 121
Annealing
stability of structural defects of polycrystalline silicon grown by rapid thermal annealing of amorphous silicon films, 1
in-situ X-ray studies of phase transformations in lead zirconate titanate thin films during annealing, 102
Atomic force microscopy
electron microscopy characterization of TiN films on Si, grown by d.c. reactive magnetron sputtering, 57

Bismuth
chemical deposition of Bi_2S_3 thin films on glass substrates pretreated with organosilanes, 49

Cadmium sulphide
chemical bath codeposited CdS–ZnS film characterization, 5
Capacitors
in-situ X-ray studies of phase transformations in lead zirconate titanate thin films during annealing, 102
Carbon
influence of nitrogen doping on different properties of a-C:H, 22
nano-tribological investigations of carbon overcoats: correlation with Raman spectra, 83
Catalysis
Langmuir–Blodgett film of glutathione S-transferase immobilised on silanized surfaces, 108
Chemical bath
chemical bath codeposited CdS–ZnS film characterization, 5
Coatings
residual stresses and stress-induced cracks in coated components, 91
thin film polarization colour-selective beamsplitter, 137
Computer simulation
infrared reflection study of CuO in thin oxide films, 45
Copper
infrared reflection study of CuO in thin oxide films, 45
Crystallization
stability of structural defects of polycrystalline silicon grown by rapid thermal annealing of amorphous silicon films, 1
in-situ X-ray studies of phase transformations in lead zirconate titanate thin films during annealing, 102

Deposition
chemical bath codeposited CdS–ZnS film characterization, 5
Deposition process
$li_2B_4O_7$ thin films prepared by the pyrosol process, 13
preparation of polyvinylcarbazole thin film with vapor deposition polymerization, 18
chemical deposition of Bi_2S_3 thin films on glass substrates pretreated with organosilanes, 49
Diamond
heteroepitaxial growth of nickel on diamond, 35
Dielectric properties
off-center effect of Cu^+-doped KCl films studied by optical absorption and thermally stimulated depolarization current, 30
Doping
influence of nitrogen doping on different properties of a-C:H, 22

Electron microscopy
electron microscopy characterization of TiN films on Si, grown by d.c. reactive magnetron sputtering, 57
Epitaxy
heteroepitaxial growth of nickel on diamond, 35
defect luminescence bands in MOCVD-grown CdTe on GaAs, 98
Evaporation
heteroepitaxial growth of nickel on diamond, 35
experiments on the microstructure of evaporated $CuInS_2$ thin films, 130
optical properties of flash-evaporated $CuIn_{0.75}Ga_{0.25}Se_2$ thin films by photoacoustic spectroscopy, 144

Fluorescence
photophysical investigation of Langmuir–Blodgett films of amphiphilic discotic penta-alkynes, 121
Fourier transform infrared spectroscopy
preparation of polyvinylcarbazole thin film with vapor deposition polymerization, 18
infrared reflection study of CuO in thin oxide films, 45

Glass
chemical deposition of Bi_2S_3 thin films on glass substrates pretreated with organosilanes, 49

Hardness
a concept for the design of novel superhard coatings, 64

Impurities
off-center effect of Cu^+-doped KCl films studied by optical absorption and thermally stimulated depolarization current, 30
optical properties of flash-evaporated $CuIn_{0.75}Ga_{0.25}Se_2$ thin films by photoacoustic spectroscopy, 144
Interfaces
residual stresses and stress-induced cracks in coated components, 91

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Langmuir–Blodgett films
Langmuir–Blodgett film of glutathione S-transferase immobilised on silanized surfaces, 108
photochemical processes in mixed Langmuir–Blodgett films of rhodamine B and anthracene, 114
photophysical investigation of Langmuir–Blodgett films of amphiphilic discotic penta-alkynes, 121
Luminescence
defect luminescence bands in MOCVD-grown CdTe on GaAs, 98

Metal–organic chemical vapour deposition
defect luminescence bands in MOCVD-grown CdTe on GaAs, 98
Metal–oxide semiconductor structure
in-situ modification of the NO_x sensitivity of thin discontinuous platinum films as gates of chemical sensors, 140
Methanol
$li_2B_4O_7$ thin films prepared by the pyrosol process, 13
Molecular beam epitaxy
thin $CuInS_2$ films by three-source molecular beam deposition, 39

Nanostructures
a concept for the design of novel superhard coatings, 64
nano-tribological investigations of carbon overcoats: correlation with Raman spectra, 83
Nickel
heteroepitaxial growth of nickel on diamond, 35
Nitric oxide
in-situ modification of the NO_x sensitivity of thin discontinuous platinum films as gates of chemical sensors, 140
Nitrogen
influence of nitrogen doping on different properties of a-C:H, 22

Optical coatings
thin film polarization colour-selective beamsplitter, 137
Optical properties
off-center effect of Cu^+-doped KCl films studied by optical absorption and thermally stimulated depolarization current, 30
optical properties of flash-evaporated $CuIn_{0.75}Ga_{0.25}Se_2$ thin films by photoacoustic spectroscopy, 144
Organic substances
chemical deposition of Bi_2S_3 thin films on glass substrates pretreated with organosilanes, 49
photochemical processes in mixed Langmuir–Blodgett films of rhodamine B and anthracene, 114
photophysical investigation of Langmuir–Blodgett films of amphiphilic discotic penta-alkynes, 121
Oxidation
infrared reflection study of CuO in thin oxide films, 45

Physical vapour deposition
preparation of polyvinylcarbazole thin film with vapor deposition polymerization, 18
Plasma processing and deposition
tensilely-stressed SiN films reactively sputtered in $Kr–N_2$ plasmas for producing free-standing devices, 152
Platinum
in-situ modification of the NO_x sensitivity of thin discontinuous platinum films as gates of chemical sensors, 140
Polymers
preparation of polyvinylcarbazole thin film with vapor deposition polymerization, 18
Pyrolysis
$li_2B_4O_7$ thin films prepared by the pyrosol process, 13

Raman scattering
nano-tribological investigations of carbon overcoats: correlation with Raman spectra, 83
Rutherford backscattering spectroscopy
thin $CuInS_2$ films by three-source molecular beam deposition, 39

Scanning tunnelling microscopy
thin $CuInS_2$ films by three-source molecular beam deposition, 39
Sensors
in-situ modification of the NO_x sensitivity of thin discontinuous platinum films as gates of chemical sensors, 140
Silane
Langmuir–Blodgett film of glutathione S-transferase immobilised on silanized surfaces, 108
Silicon
stability of structural defects of polycrystalline silicon grown by rapid thermal annealing of amorphous silicon films, 1
Silicon nitride
a concept for the design of novel superhard coatings, 64
tensilely-stressed SiN films reactively sputtered in $Kr–N_2$ plasmas for producing free-standing devices, 152
Solar cells
optical properties of flash-evaporated $CuIn_{0.75}Ga_{0.25}Se_2$ thin films by photoacoustic spectroscopy, 144
Sputtering
electron microscopy characterization of TiN films on Si, grown by d.c. reactive magnetron sputtering, 57
tensilely-stressed SiN films reactively sputtered in $Kr–N_2$ plasmas for producing free-standing devices, 152
Stress
complex XRD microstructural studies of hard coatings applied to PVD-deposited TiN films. Part II. Transition from porous to compact films and microstructural inhomogeneity of the layers, 72
residual stresses and stress-induced cracks in coated components, 91
tensilely-stressed SiN films reactively sputtered in $Kr–N_2$ plasmas for producing free-standing devices, 152
Structural properties
stability of structural defects of polycrystalline silicon grown by rapid thermal annealing of amorphous silicon films, 1
complex XRD microstructural studies of hard coatings applied to PVD-deposited TiN films. Part II. Transition from porous to compact films and microstructural inhomogeneity of the layers, 72
experiments on the microstructure of evaporated $CuInS_2$ thin films, 130
Sulphides
chemical deposition of Bi_2S_3 thin films on glass substrates pretreated with organosilanes, 49
experiments on the microstructure of evaporated $CuInS_2$ thin films, 130
Sulphur
thin $CuInS_2$ films by three-source molecular beam deposition, 39
Surface morphology
experiments on the microstructure of evaporated $CuInS_2$ thin films, 130

Titanium nitride
electron microscopy characterization of TiN films on Si, grown by d.c. reactive magnetron sputtering, 57
a concept for the design of novel superhard coatings, 64
complex XRD microstructural studies of hard coatings applied to PVD-deposited TiN films. Part II. Transition from porous to compact films and microstructural inhomogeneity of the layers, 72
Tribology
nano-tribological investigations of carbon overcoats: correlation with Raman spectra, 83
X-ray diffraction
complex XRD microstructural studies of hard coatings applied to PVD-deposited TiN films. Part II. Transition from porous to compact films and microstructural inhomogeneity of the layers, 72
in-situ X-ray studies of phase transformations in lead zirconate titanate thin films during annealing, 102
Zinc sulphide
chemical bath codeposited CdS–ZnS film characterization, 5